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1. (CURRENTLY AMENDED) A method of making a diode laser assembly, comprising:
providing a substrate;
forming an epitaxial structure on the substrate, the epitaxial structure having optically active and optically inactive areas;
forming a laser in the epitaxial structure, the laser including first and second reflectors, a gain section and a phase section, the gain section and the phase section each being positioned between the first and second reflectors to produce a tunable laser output therefrom; and
forming an amplifier in the epitaxial structure, at least a portion of the laser and amplifier sharing a common waveguide, the tunable laser output being coupled to the amplifier along the common waveguide, and the amplifier generating an optical signal in response to the coupled tunable laser output, wherein at least a portion of the waveguide is curved ~~and the waveguide intersects to reduce reflections from an output facet at an oblique angle.~~
 2. (ORIGINAL) The method of claim 1, wherein the optically active areas of the epitaxial structure are formed using off-set quantum wells.
 3. (ORIGINAL) The method of claim 1, wherein the optically inactive areas are formed by a selective area growth.
 4. (ORIGINAL) The method of claim 1, wherein the optically inactive areas are formed by a selective area growth using a dielectric mask.
 5. (ORIGINAL) The method of claim 1, wherein the optically inactive areas are formed by selective area disordering.
 6. (ORIGINAL) The method of claim 1, wherein the optically inactive areas are formed by butt joint regrowth.
 7. (CURRENTLY AMENDED) The method of claim 1, wherein the optically inactive areas are formed with multiple quantum well layers ~~grow~~ grown on top of the waveguide layer.

8. (ORIGINAL) The method of claim 1, further comprising:
forming areas of different bandgaps in the epitaxial structure.
9. (CURRENTLY AMENDED) The method of claim 1, further comprising:
bombarding at least a portion of the epitaxial structure with ions; and
tailoring a bandgap of at least a portion of the epitaxial structure to create a the gain medium
section of the laser.
10. (ORIGINAL) The method of claim 9, further comprising:
annealing at least a portion of the epitaxial structure to diffuse impurities and vacancies in a
selected region of the epitaxial structure to determine the region's optical properties.
11. (PREVIOUSLY AMENDED) The method of claim 9, wherein the ions have an energy
no greater than about 200 eV.
12. (ORIGINAL) The method of claim 1, wherein the amplifier includes a first active region
and a passive region.
13. (ORIGINAL) The method of claim 12, wherein the waveguide extends through at least a
portion of the amplifier.
14. (ORIGINAL) The method of claim 13, wherein the waveguide extends through the first
active region and the passive region.
15. (ORIGINAL) The method of claim 14, wherein a distal portion of the waveguide in the
amplifier is curved.
16. (ORIGINAL) The method of claim 14, wherein a distal portion of the waveguide in the
amplifier is curved and the amplifier includes a tapered section.
17. (ORIGINAL) The method of claim 14, wherein a distal end of the waveguide in the
amplifier terminates at an oblique angle to an output facet.

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~~38~~ 18. (ORIGINAL) The method of claim 1, wherein at least a portion of the waveguide is tapered.

~~20~~ 19. (PREVIOUSLY AMENDED) The method of claim ~~23~~¹⁹, wherein the waveguide includes an active section.

~~22~~ 20. (ORIGINAL) The method of claim ~~19~~²⁰, wherein the active section of the waveguide is positioned in the first active section of the amplifier.

~~20~~ 21. (ORIGINAL) The method of claim ~~19~~²⁰, wherein the active section of the waveguide is positioned in the second active section of the amplifier.

~~18~~ 22. (ORIGINAL) The method of claim 12, wherein the first active region has a tapered distal face.

~~19~~ 23. (ORIGINAL) The method of claim 12, wherein the amplifier includes a second active region.

~~23~~ 24. (ORIGINAL) The method of claim ~~23~~¹⁹, wherein the first and second active regions are separated by a passive region.

~~24~~ 25. (ORIGINAL) The method of claim ~~24~~²³, wherein the first active region has a tapered distal face.

~~25~~ 26. (ORIGINAL) The method of claim ~~25~~²⁴, wherein the second active region has a tapered proximal face.

~~28~~ 27. (ORIGINAL) The method of claim ~~26~~²⁵, wherein the tapered distal face of the first active region is parallel to the tapered proximal face of the second active region.

²⁴ 28. (ORIGINAL) The method of claim ²⁵ 26, wherein the second active region has a tapered distal face.

²⁷ 29. (ORIGINAL) The method of claim ²⁶ 28, wherein the proximal face and the distal face of the second region are parallel.

²⁹ 30. (CURRENTLY AMENDED) The method of claim 1, wherein ~~the laser includes first and second reflectors~~, at least one of the first and second reflectors ~~being~~ is a distributed Bragg reflector.

³⁰ 31. (ORIGINAL) The method of claim ²⁹ 30, wherein a maximum reflectivity of at least one of the first and second reflectors is tunable.

³¹ 32. (ORIGINAL) The method of claim ³⁰ 31, wherein the maximum reflectivities of each of the first and second reflectors are tunable relative to each other.

³¹ 33. (CURRENTLY AMENDED) A method of making a diode assembly, comprising:

- providing a substrate;
- forming a first semiconductor layer and a second semiconductor layer in an epitaxial structure having optically active and optically ~~in-active~~ inactive areas, the first and second semiconductor layers having different dopings; and
- forming a first waveguide layer between the first and second semiconductor layers, the first waveguide layer including a waveguide, a first reflector and a second reflector ;
- forming an optically active medium disposed between the first and second reflectors, the first and second reflectors defining a laser cavity and producing a tunable laser output; and
- forming an amplifier in the epitaxial structure, wherein the laser cavity and the amplifier are optically aligned, the tunable laser output being coupled into the amplifier along the waveguide, and the amplifier generating an optical signal in response to the coupled tunable laser output, wherein at least a portion of the waveguide is curved ~~and the waveguide intersects~~ to reduce reflections from an output facet at an oblique angle.

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⁷² 34. (ORIGINAL) The method of claim ³⁹33, wherein the optically active areas in the epitaxial structure are formed using off-set quantum wells.

⁷³ 35. (ORIGINAL) The method of claim ³⁹33, wherein the optically inactive areas in the epitaxial structure are formed by a selective area growth.

⁷⁴ 36. (ORIGINAL) The method of claim ³⁹33, wherein the optically inactive areas are formed by a selective area growth using a dielectric mask.

⁷⁵ 37. (ORIGINAL) The method of claim ³⁹33, wherein the optically inactive areas are formed by selective area disordering.

⁷⁶ 38. (ORIGINAL) The method of claim ³⁹33, wherein the optically inactive areas are formed by butt joint regrowth.

⁷¹ 39. (ORIGINAL) The method of claim ³⁹33, wherein the optically inactive areas are formed with multiple quantum well layers grow on top of the waveguide layer.

40. (ORIGINAL) The method of claim ³⁹33, further comprising:
forming areas of different bandgaps in the epitaxial structure.

41. (PREVIOUSLY AMENDED) The method of claim ³⁹33, further comprising:
bombarding at least a portion of the epitaxial structure with ions; and
tailoring a bandgap of at least a portion of the epitaxial structure to create a gain medium of the laser.

42. (ORIGINAL) The method of claim 41, further comprising:
annealing at least a portion of the epitaxial structure to diffuse impurities and vacancies in a selected region of the epitaxial structure to determine the region's optical properties.

43. (PREVIOUSLY AMENDED) The method of claim 41, wherein the ions have an energy no greater than about 200 eV.

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44. (ORIGINAL) The method of claim ~~38~~, wherein the amplifier includes a first active region and a passive region.

45. (ORIGINAL) The method of claim 44, wherein the waveguide layer includes a waveguide that extends through at least a portion of the amplifier.

46. (ORIGINAL) The method of claim 45, wherein the waveguide extends through the first active region and the passive region.

47. (ORIGINAL) The method of claim 46, wherein a distal portion of the waveguide in the amplifier is curved.

48. (ORIGINAL) The method of claim 46, wherein a distal portion of the waveguide in the amplifier is curved and the amplifier includes a tapered section.

49. (ORIGINAL) The method of claim 46, wherein a distal end of the waveguide in the amplifier terminates at an oblique angle to an output facet.

50. (ORIGINAL) The method of claim 45, wherein at least a portion of the waveguide is tapered.

52-51 (PREVIOUSLY AMENDED) The method of claim ~~50~~, wherein the waveguide includes an active section.

54-52 (ORIGINAL) The method of claim ~~51~~, wherein the active section of the waveguide is positioned in the first active section of the amplifier.

53-52 (ORIGINAL) The method of claim ~~51~~, wherein the active section of the waveguide is positioned in the second active section of the amplifier.

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54. (ORIGINAL) The method of claim 44, wherein the first active region has a tapered distal face.

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55. (ORIGINAL) The method of claim 44, wherein the amplifier includes a second active region.

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56. (ORIGINAL) The method of claim 55, wherein the first and second active regions are separated by a passive region.

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57. (ORIGINAL) The method of claim 56, wherein the first active region has a tapered distal face.

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58. (ORIGINAL) The method of claim 57, wherein the second active region has a tapered proximal face.

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59. (ORIGINAL) The method of claim 58, wherein the tapered distal face of the first active region is parallel to the tapered proximal face of the second active region.

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60. (ORIGINAL) The method of claim 58, wherein the second active region has a tapered distal face.

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61. (ORIGINAL) The method of claim 60, wherein the proximal face and the distal face of the second region are parallel.

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62. (ORIGINAL) The method of claim 39, wherein at least one of the first and second reflectors is a distributed Bragg reflector.

63. (ORIGINAL) The method of claim 62, wherein a maximum reflectivity of at least one of the first and second reflectors is tunable.

64. (ORIGINAL) The method of claim 63, wherein the maximum reflectivities of each of the first and second reflectors are tunable relative to each other.

~~32~~ 65. (PREVIOUSLY ADDED) The method of claim 1, wherein at least a portion of the waveguide is non-parallel to an axis of the laser's cavity.

~~33~~ 66. (PREVIOUSLY ADDED) The method of claim 1, wherein a width of the tunable laser output is independent of a width of the waveguide at an output of the amplifier.

~~34~~ 67. (PREVIOUSLY ADDED) The method of claim 1, wherein at least a portion of the waveguide is flared-out in an active section of the amplifier and flared-in in a passive section of the amplifier.

B ~~35~~ 68. (PREVIOUSLY ADDED) The method of claim 1, further comprising a waveguide mode adapter to enlarge an optical mode near the output facet so that it is more closely matched to the mode in an optical fiber that carries the light away from the output facet.

~~36~~ 69. (PREVIOUSLY ADDED) The method of claim ~~35~~ 68, wherein the waveguide mode adapter includes a section of passive waveguide and the waveguide's cross section is varied to expand the waveguide's optical mode in an adiabatic manner.

~~37~~ 70. (PREVIOUSLY ADDED) The method of claim 1, wherein the optical signal is tunable within a range of at least 15 nm.

~~65~~ ~~37~~ 71. (PREVIOUSLY ADDED) The method of claim ~~35~~ 68, wherein at least a portion of the waveguide is non-parallel to an axis of the laser cavity.

~~66~~ ~~37~~ 72. (PREVIOUSLY ADDED) The method of claim ~~35~~ 68, wherein a width of the tunable laser output is independent of a width of the waveguide at an output of the amplifier.

~~67~~ ~~37~~ 73. (PREVIOUSLY ADDED) The method of claim ~~35~~ 68, wherein at least a portion of the waveguide is flared-out in an active section of the amplifier and flared-in in a passive section of the amplifier.

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~~74.~~ (PREVIOUSLY ADDED) The method of claim ~~33~~³⁹, further comprising a waveguide mode adapter to enlarge an optical mode near the output facet so that it is more closely matched to the mode in an optical fiber that carries the light away from the output facet.

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~~75.~~ (PREVIOUSLY ADDED) The method of claim ~~74~~⁶⁸, wherein the waveguide mode adapter includes a section of passive waveguide and the waveguide's cross section is varied to expand the waveguide's optical mode in an adiabatic manner.

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~~76.~~ (PREVIOUSLY ADDED) The method of claim ~~33~~³⁹, wherein the optical signal is tunable within a range of at least 15 nm.